



IPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Cui et al.	Group Art Unit: 2823
Application No: 10/824,313	Examiner: Khiem D. Nguyen
Confirmation No: 5975	Attorney Docket No:
Filed: April 13, 2004	007034 USA P03/DSM/BCVD/JW
Title: ELECTRON BEAM TREATMENT OF Si _x N _y FILMS	February 23 rd , 2005 San Francisco, California

RESPONSE TO OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

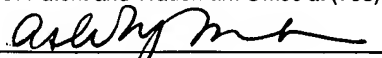
Examiner Nguyen:

This communication is in response to the Office Action mailed on
November 23, 2004, and is being filed within three months thereof.

Certificate of Transmission

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, or facsimile transmitted to the U.S. Patent and Trademark Office at (703) 872-9306 on the date shown below.

By:


Ashok Janah

Date: February 23, 2005